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Patent Application 2771-357 DIV (7486)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Applicant: VAN BUSKIRK et al.

Application No.: 09/928,860

Date Filed:

August 13, 2001

Title:

SCALABLE LEAD ZIRCONIUM TITANATE (PZT) THIN FILM MATERIAL AND DEPOSITION METHOD, AND FERROELECTRIC MEMORY DEVICE STRUCTURES COMPRISING SUCH THIN FILM MATERIAL Docket No.:

2771-357 DIV

Examiner:

FULLER, Eric B.

Art Unit:

1762

Confirm. No.:

8391

Customer No.:

25559

FACSIMILE TRANSMISSION CERTIFICATE ATTN: Examiner Eric B. FULLER

Fax No.: (703) 872-9306

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on June 2, 2005, to United States Patent and Trademark Office facsimile transmission number (703) 872-9306.

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Number of Pages (including cover)	
Justa a. I	
Tristan A. Fuierer	
June 2, 2005	
Date	

RESPONSE TO MARCH 8, 2005 OFFICE ACTION IN UNITED STATES PATENT APPLICATION NO. 09/928,860

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir/Madam:

Dear Sir:

This responds to the March 8, 2005 Office Action in the above-identified patent application.

Patent Application 2771-357 DIV (7486)

Please amend the claims of the application as set out in Section I (Amendment to the Claims).

Remarks addressing the substance of the March 8, 2005 Office Action are set out in Section II (Remarks) hereof.